

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Hideaki Shiraishi

Examiner:

Dung T. Nguyen

Serial No.:

09/774,921

Art Unit:

2871

Filed:

January 31, 2001

Docket:

14274

For:

METHOD OF

Dated:

February 3, 2004

FABRICATING LIQUID

CRYSTAL DISPLAY

SUBSTRATE AND THE SAME

Commissioner for Patents United States Patent and Trademark Office P.O. Box 1450, Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

Sir:

In accordance with 37 C.F.R. §§1.97 and 1.98, it is requested that the following references, which are also listed on the attached Form PTO-1449, be made of record in the above-identified case.

- 1. Microfilm of Japanese Utility Model Application No. Showa 51-123239 (Japanese Unexamined Utility Model Application No. 53-041945 dated April 11, 1978).
- 2. Japanese Unexamined Patent Application No. 03-258476, dated November 18, 1991; together with English-Language Abstract
- 3. Japanese Unexamined Patent Application No. 11-160667, dated June 18, 1999; together with English-Language Abstract

CERTIFICATE OF MAILING UNDER 37 C.F.R. §1.8(a)

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on February 3, 2004.

Dated:

February 3, 2004

Anthony N. Fresco

02/10/2004 SMINASS1 00000059 09774921

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4. Japanese Unexamined Patent Application No. 11-014953, dated January 22, 1999; together with English-Language Abstract

The references were cited in an Official Action dated January 7, 2004 received from the Japanese Patent Office. Applicant is submitting copies of the above-cited references, together with a translation of the Examiner's comments regarding the references from the Official Action. Please note that Japanese Unexamined Patent Application No. 59-182421 has been previously submitted in an Information Disclosure Statement dated June 14, 2002. The relevance of the references is described in the Official Action.

In compliance with the requirements of 37 C.F.R. §1.98(a)(3), as a concise statement of relevance, as it is presently understood by the individual designated in 37 C.F.R. §1.56(c) most knowledgeable about the content of the information, the undersigned submits a translation of portions of an official action by a foreign examiner in which the references were cited. The relevance to the pending U.S. patent application is that the references were cited in a foreign patent application on the same subject matter. However, no independent analysis of the references, the accuracy of the statement of the foreign examiner or the claims of the foreign application under the laws of that country or the United States relative to the subject matter claimed in the present application has been made; the present understanding of the contents thereof by the undersigned being based on the translation of the foreign examiner's comments submitted herewith.

Inasmuch as this Information Disclosure Statement is being submitted in accordance with the schedule set out in 37 C.F.R. §1.97(d), the \$180.00 fee and statement are enclosed.

Respectfully submitted,

Anthony N. Fresco

Registration No. 45,784

SCULLY, SCOTT, MURPHY & PRESSER 400 Garden City Plaza Garden City, New York 11530 (516) 742-4343/4366 Fax

ANF:yd

TRANSMITTAL O	Docket No. 14274											
In Re Application Of: Hideaki Shiraishi												
Serial No.	Filing Date 3 d 1 0	Examiner		Group Art Unit								
09/774,921	January 31, 2001	Dung T. Nguyen	2871									
Title: METHOD OF FABRICATING LIQUID CRYSTAL DISPLAY SUBSTRATE AND THE SAME												
Commissioner for Patents The Information Disclosure Statement submitted herewith is being filed after the period specified in 37 CFR 1.97(c), and on or before payment of the issue fee, and is accompanied by the Statement as specified in 37 CFR 1.97(e) and the fee set forth in 37 CFR 1.17(p). A check in the amount of \$180.00 is attached. Charge Deposit Account No. in the amount of Certificate of Transmission by Facsimile* Certificate of Mailing by First Class Mail												
I certify that this document and authorization to charge deposit account is being facsimile transmitted to the United States Patent and Trademark Office (F Continue												



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FABRICATING LIQUID CRYSTAL DISPLAY

SUBSTRATE AND THE SAME

Commissioner for Patents

P.O. Box 1450, Alexandria, VA 22313-1450

STATEMENT PURSUANT TO 37 C.F.R. §§1.97(d) and (e)(1)

Sir:

I hereby state that each item of information contained in this Information Disclosure Statement was first cited in any communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this Information Disclosure Statement. Applicant also submits the requisite \$180.00 official fee pursuant to §1.17(p) by means of the enclosed check.

Respectfully submitted,

Anthony N. Fresco Registration No. 45,784

Scully, Scott, Murphy & Presser 400 Garden City Plaza Garden City, New York 11530 (516) 742-4343/4366 Fax

CERTIFICATE OF MAILING UNDER 37 C.F.R. §1.8(a)

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Dated: February 3, 2004

Anthony N. Fresco

INFORMATION DISCLOSURE CITATION				Docket Number (Optional)		Application Number						
INFORMATION DISCLOSURE CITATION				14274 09/774,921 Applicant(s) Hideaki Shiraishi								
R O	(Use several sheets if necessary)				Filing Date Group Art Unit							
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Balo) /			U.S. PAT	ENT DOCUMENTS							
*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE		NAME CLA		SUBCLASS	FILING DATE IF APPROPRIATE				
			1	FOREIG	N PATENT DOCUMENTS							
	REF	DOCUMENT NUMBER	DATE	COUNTRY CLA		CLASS	SUBCLASS	Translation YES NO				
		03-258476	11/18/1991	Japan				123	NO			
		11-160667	6/18/1999	Japan								
		11-014953	1/22/1999	Japan					-			
		*53-041945	4/11/1978	Japan				,				
•				OTHER	DOCUMENTS (Including)	Author, Title,	Date, Pertinent Pa	ges, Etc.)				
	T	* Microfilm of Japanese	Utility Model App	plication N	o. Showa 51-123239 No. 53-041945 dated April	11 1978)						
		(vapanese onexamme	u Otiniy Would Ap	pileation i	10. 55-041245 dated April	11, 17, 0,						
EXAMINER				DATE CONSIDERED								
	EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.											